



IPW

Atty. Dkt. No 023312-0109

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Takashi NAGASE et. al.  
Title: METHOD OF MANUFACTURING NANO-GAP  
ELECTRODE  
Appl. No.: 10/662,886  
Filing Date: 09/16/2003  
Examiner: Ahmed, Shamim  
Art Unit: 1765

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants hereby petition the Commissioner under 37 C.F.R. §1.136(a) for a three-month extension of time for response in the above-identified application for the period required to make the attached response timely.

The extension fee for response within the third month is \$1,020.00. A check for this amount is enclosed herewith.

The Commissioner is hereby authorized to charge any additional fees which may be required regarding this application under 37 C.F.R. §§ 1.16-1.17, or credit any overpayment, to Deposit Account No. 19-0741. Should no proper payment be enclosed herewith, as by a check being in the wrong amount, unsigned, post-dated, otherwise improper or informal or even entirely missing, the Commissioner is authorized to charge the unpaid amount to Deposit Account No. 19-0741.

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Respectfully submitted,

Date December 7, 2005

By

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